



PATENT
USSN 10/727,429
Atty. Docket No. 8448-90969

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Confirmation No. 6834
)	
Ghansshyam S. Mishra et al.)	Group Art Unit: 1754
)	
For: NEW REACTOR FOR PRODUC-)	Examiner: Alvin T. Raetzsch
ING LOWSURFACE AREA HIGH/)	
LOW STRUCTURE CARBON)	
BLACK AND SIMUTANEOUSLY)	
MINIMIZING THE FORMATION)	
OF GRIT)	
)	
)	
Serial No. 10/727,429)	
)	
Filed: December 4, 2003)	

AMENDMENT A UNDER RULE 111

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Examiner's action mailed on April 4, 2006, applicants request that the application be amended as follows:

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop _____, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this date.

Date

Registration No. 24,543
Attorney for Applicant(s)